

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Naoto NAKAMURA et al.

Application No.: New U.S. National Stage of  
PCT/JP03/012353

Filed: March 15, 2005

Docket No.: 122733

For: THERMAL TREATMENT APPARATUS, METHOD FOR MANUFACTURING  
SEMICONDUCTOR DEVICE, AND METHOD FOR MANUFACTURING SUBSTRATE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

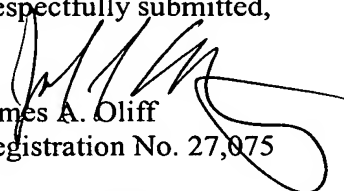
Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. The references were cited in the International Search Report. An English language version of the International Search Report is attached for the Examiner's information.
- ☒ 3. English language Abstracts of the non-English language references (1-7) are attached hereto.

DT15 Rec'd PCT/PTO 5 MAR 2005

- ☒ 4. A computer-generated English language translation of the following Japanese references has been obtained from the website of the Japanese Patent Office (<http://www.jpo.go.jp>), and is attached, but has not been reviewed for accuracy. See References 1-7.

Respectfully submitted,

  
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JAO:JSA/crh

Date: March 15, 2005

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<p>DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>
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Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 122733		APPLICATION NO. New U.S. National Stage of PCT/JP03/012353 <b>10/528069</b>	
INFORMATION DISCLOSURE STATEMENT  (Use several sheets if necessary)				APPLICANTS Naoto NAKAMURA et al.			
				FILING DATE March 15, 2005			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
	1	JP 11-340155 w/ abstr. & trans.	12/10/1999	Japan			
	2	JP 10-242067 w/ abstr. & trans.	09/11/1998	Japan			
	3	JP 07-161654 w/ abstr. & trans.	06/23/1995	Japan			
	4	JP 10-242254 w/ abstr. & trans.	09/11/1998	Japan			
	5	JP 2002-231726 w/ abstr. & trans.	08/16/2002	Japan			
	6	JP 2001-358086 w/ abstr. & trans.	12/26/2001	Japan			
	7	JP 09-260470 w/ abstr. & trans.	10/03/1997	Japan			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
EXAMINER					DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: March 15, 2005